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In re application of

TOMOHIRO OKUMURA ET AL

Serial No. 09/918,823 :

Filed: August 1, 2001 :

Title: Plasma processing method and apparatus theeof

Attn: Office of Initial Patent

Examination Customer Service

Center

## REQUEST FOR CORRECTED FILING RECEIPT

Assistant Commissioner for Patents, Washington, D. C.

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked in red indicating corrections to be made thereto.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

TOMOHIRO OKUMURA ET AL

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June 17, 2002



## United States Patent and Trademark Office

COMMISSIONER FOR PATENTS UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON, D.C. 20231 www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/918,823	08/01/2001	2817	1280	2001_1089A	7	40	4

**CONFIRMATION NO. 4423** 

UPDATED FILING RECEIPT

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000513 WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 **WASHINGTON, DC 20006-1021** 

Date Mailed: 11/26/2001

ECHNOLOGY CENTER 2800

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

Foreign Applications

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Projected Publication Date: 03/07/2002

Non-Publication Request: No

Early Publication Request: No

Title

Plasma processing method and apparatus thereof

**Preliminary Class** 

315



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Bib Data Sheet

**CONFIRMATION NO. 4423** 

SERIAL NUMBER 09/918,823	FILING DATE 08/01/2001 RULE	<b>CLASS</b> 315	GROUP ART 2821		ATTORNEY DOCKET NO. 2001_1089A		
Yukihiro Mae Izuru Matsuda ** CONTINUING DA ** FOREIGN APPLI JAPAN 2000-	umura, Kadoma-shi, JAPA gawa, Ibaraki-shi, JAPAN; a, Ibaraki-shi, JAPAN; ATA ***********************************	; ;*					
Foreign Priority claimed 35 USC 119 (a-d) conditio met Verified and	ANOMADO	er COUNTRY JAPAN	SHEETS DRAWING 7	TOTAI CLAIM 40			
TITLE Plasma processing	method and apparatus the	ereof					
RECEIVED No	ES: Authority has been gi to charge/cr for following	edit DEPOSIT ACCOU	JNT   1.1	☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			